CALIFORNIA INSTITUTE OF TECHNOLOGY			DCN N	DCN No. E980075				
LIGO	MASSACHUSETT	S INSTITUTE OF TECH	CHNOLOGY	SHEE	т 1	OF	1	
DOCUME	MT CHANC	C NOTIC	C (DON)					
	NT CHANG	ENOTIC	E (DCN)					
DOCUMENT No. (DOC-REV-GP. ID)			TITLE				NEW REV.	
D960133-B-D	Large Optic Sus	pension Struc	ture Assembly				C	
D970551-B-D	Recycling Mirro	=	•				C	
			are rissemory					
							+	
CHANGE DESCRIPTION (FROM/TO	<u> </u>							
•	•							
Include location and mount								
Include conversion of Table	e 1 Chamfer Stop	Vectors to ro	tations and translati	ions from too	ling ba	ll. sh€	et 84	
	•					, 5	701	
REASON FOR CHANGE: Vendo	r found locating	chamfer stop	start points easier us	sing tooling b	oalls.			
ACTION: Incorporate change	Attach DCN to	o drawing(s)	Other action (specify)	:				
DISPOSITION OF HARDWARE (IDENTIFY SERIAL NUMBERS)				DC	DCN DISTRIBUTION			
No hardware affected (record change only)				Althouse	Barish	Co	les	
List S/Ns which comply alrea	ıdy:			Covne	Lazzarin		dquist	
List S/Ns to be reworked or s	crapped:			Stapfer	Sanders Tyler	Sno	oemaker	
List S/Ns to be built with this change:				Weiss	Whitcom	b		
List S/Ns to be retested per t	his change:			XFine				
	-			X inclu				
						,/ 1	,	
				X inclu	deai	Yachi	ment	
				mdu	stribu	inou		
Ц								
SAFETY, COST, SCHEDULE, REQU	JIREMENTS IMPACT?	□ No □	Yes (If yes, enter CR (CC	B) or TCP (TRB)	no.)	
APPROVALS:		DATE	OTHER APPRO	OVALS (specify)		D	ATE	

4-1-98

J. Hazel

ORIGINATOR: J. F.
TASK LEADER:
GROUP LEADER:
DCC RELEASE:

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